

## Electronic Acknowledgement Receipt

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Application Number:	10711649
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Title of Invention:	A METHOD FOR SUPERCRITICAL CARBON DIOXIDE PROCESSING OF FLUORO-CARBON FILMS
First Named Inventor:	Kohei Kawamura
Customer Number:	37694
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### File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Information Disclosure Statement (IDS) Filed	US_IDS_Form__SB_08a.pdf	4235949	no	6

### Warnings:

2	Information Disclosure Statement (IDS) Filed	WO03064065A1.pdf	2272210	no	27
<b>Warnings:</b>					
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		<b>Total Files Size (in bytes):</b>		6508159	
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